PATENT Atty. Dkt. No. APPM/005867/PPC/ECP/CKIM Serial No.: 10/074,353

This

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Wang, et al.

Serial No.: 10/074,353

Confirmation No.: 6841

Filed:

February 11, 2002

For:

Method of Annealing Metal

Layers

๛๛๛๛๛๛๛๛๛๛๛

Group Art Unit: 2818

Examiner:

Thao P. Le

MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING 37 CFR 1.8

I hereby certify that this correspondence is being deposited on 211, 2006 with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

ate B. Todd

RESPONSE TO OFFICE ACTION DATED NOVEMBER 2, 2005

In response to the Office Action dated November 2, 2005, having a shortened statutory period for response set to expire on February 2, 2006, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/005867/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Specification begin on page 2 of this paper. Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper. Remarks begin on page 13 of this paper.